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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2813

Examiner: Jack S. J. CHEN

In Re PATENT APPLICATION Of:

Applicant(s): Toshikazu MIZUKOSHI

Serial No.: 10/635,506

Filed: August 7, 2003

For: METHOD OF FABRICATING A  
SEMICONDUCTOR DEVICE HAVING  
TRENCHES

Docket No.: OKI 361

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)  
) **REQUEST FOR**  
) **ACKNOWLEDGMENT OF**  
) **INFORMATION**  
) **DISCLOSURE**  
) **STATEMENT AND**  
) **FORM PTO-1449**  
)  
)  
)

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Applicant's original Information Disclosure Statement and Form PTO-1449, listing two U.S. Patents and two Japanese patent publications and their English-language abstracts, submitted on April 9, 2004, were apparently lost by the United States Patent and Trademark Office. Evidence of submission is provided by attaching hereto a copy of the date-stamped Post Card receipt. Also attached are the originally filed Information Disclosure Statement and Form PTO-1449, and the two Japanese publications and related Abstracts.

Consideration of the previously filed Information Disclosure Statement, Form PTO-1449 and the references listed therein is respectfully requested.

Respectfully submitted,

Robert H. Berdo, Jr.

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June 30, 2004

Date

RHB:vm

FEE ENCLOSED: \$  
Please charge any further  
fee to our Deposit Account  
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RECEIPT NO. 17195 DATE: April 9, 2004  
DOCKET NO. OKI 361

APPLICANT(S): Toshikazu MIZUKOSHI  
SERIAL NO.: 10/635,506  
FILED: August 7, 2003  
FOR: Method of Fabricating A  
Semiconductor Device Having  
Trenches

PAPERS FILED:

- 1) Information Disclosure Statement
- 2) PTO-1449
- 3) 2 Japanese Publications (2 US Patents Listed)



***\*PLEASE DATE STAMP AND RETURN\****

FORM PTO-1449

## INFORMATION DISCLOSURE STATEMENT



COPY

Atty. Docket:  
OKI 361Application No.:  
10/635,506Applicant:  
Toshikazu MIZUKOSHIFiling Date:  
August 7, 2003Group Art Unit:  
2813

## U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA	US 6, 599,811 B1	07/29/03	Kazama et al.			
	AB	US 6,566,224 B1	05/20/03	Chang et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Trans-lation
	AI	JP 11-233614	08/27/99	Japan			Abstract
	AJ	JP 11-097523	04/09/99	Japan			Abstract
	AK						
	AL						
	AM						

## OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

	AN	
	AO	

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.